

Notice of References Cited	Application/Control No. 10/566,052		Applicant(s)/Patent Under Reexamination HOFFMANN ET AL.	
	Examiner MICHAEL LAVILLA		Art Unit 1794	Page 1 of 1

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	U	Machine Translation, Noda JP 2001-205443 (07-2001).
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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